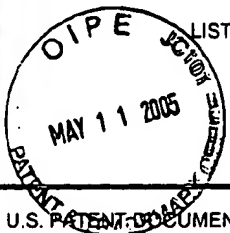


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1398		SERIAL NO. 09/536,037	
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT: Li et al.			
				FILING DATE March 27, 2000		GROUP 2822	
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							Yes No
JmJ	AJ	TW 471112A TW 47112A	01/01/2002	Taiwan - Abstract			X
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	AM	Wolf, S., and Tauber, Richard, Silicon Processing for the VLSI Era; Vol. 1; Process Technology; "Silicon: Single Crystal Growth and Wafer Preparation"; pages 1 and 2					
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EXAMINER J.M. Thomey		DATE CONSIDERED 12-08-05					
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	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AJ						
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	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
EXAMINER J. M. Thomas		DATE CONSIDERED 12-08-05					
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